

C-MOS Gate-Array

TS288

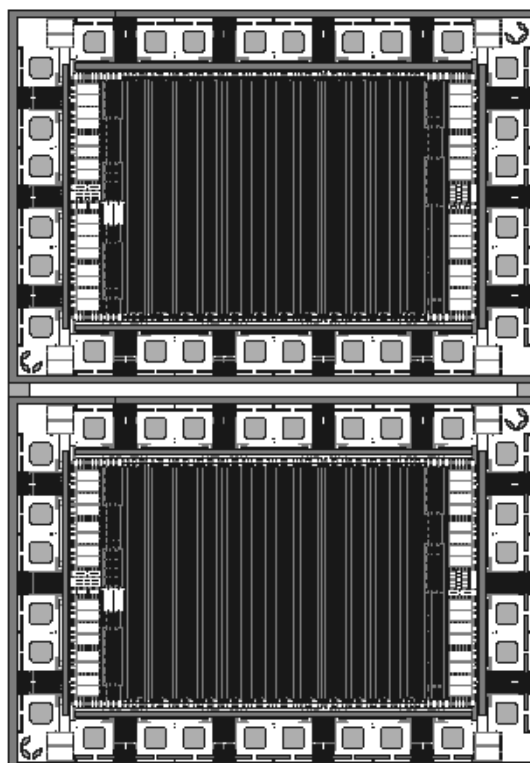
DESCRIPTION

The TS288 is a semicustom masterchip built in a single metal C-MOS technology. The main application of this component array is to realize mixed-signal ASICs (Application Specific Integrated Circuits) of moderate complexity in a rather short development time and with low development costs. The chip contains a lot of different active and passive components which can be interconnected by a single customized metal mask. The larger part of the TS288 has a gate-array structure which is mainly used for digital circuits. In addition to the gate array part, it contains an analog section with transistors of different sizes, diodes, resistors and capacitors. This part can be used to realize numerous analog functions. The available components and the low threshold voltage of the employed C-MOS process make the TS288 specially suited to build low current and low voltage circuits.

FEATURES

- Digital part: 2'888 transistor pairs (N-MOS and P-MOS)
- Analog part: Separate N-MOS and P-MOS transistors, diodes, low and high value resistors, floating capacitors
- 40 input/output cells
- Programmable by a single metal mask
Very flexible wiring possibilities
- Processed with the proven SACMOS technology of PHILIPS SEMICONDUCTORS
- Supply voltage range: 0.9V to 6.5V
- High speed operation: min. 100MHz toggle frequency at $V_{DD} = 4.5V$
- Small chip size: 2.30mm x 3.22mm
Encapsulation in SO8 package possible

LAYOUT



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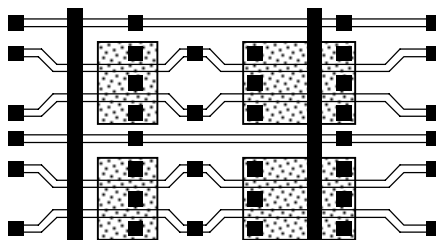
SHORT PROCESS DESCRIPTION

- N-well silicon-gate C-MOS process
- Low ohmic substrate with epitaxial layer guaranties a latch-up free circuit behaviour
- 2µm feature size
- Self aligned contacts (SAC) results in a 4µm unrestricted pitch for metal interconnections
- Low threshold voltage: 0.60V ± 0.15V for N-MOS and P-MOS transistors
- Operating voltage range: 0.9V to 6.5V. Maximum rating: 7.0V
- Sheet resistance of polysilicon: 30Ω/square
- Sheet resistance of metal: 25mΩ/square

DIGITAL PART

- 2'784 transistor pairs standard sized (N: 10/2 P: 16/2)
- 104 transistor pairs with small dimensions (N: 3/2 P: 5/2) specially suited for lower current frequency dividers
- 40 input/output cells
- The basic transistor pairs can be connected with the metal mask into NOR and NAND gates with any number of inputs, into transmission gates, combined logic functions, latches, flip-flops, etc.
- Organized in 12 rows of 232 transistor pairs each
- Routing channels with 10 interconnect lines between the logic rows

Layout of the basic transistor pair structure



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ANALOG PART

MOS TRANSISTORS

Size	Width (μm)	Length (μm)	Number (N and P each)
A	6	5	112 x 3
S	3	2	48 x 2
H	3	30	8 x 2

There are three different transistor geometries in the analog part.

The transistors of size A are mainly used for amplifiers and comparators. The 5μm gate length results in a lower offset voltage and higher gain for the amplifier than the standard 2μm gate length. The small transistors of size S are used in switched capacitor applications in order to minimize gate feed-through. The long and narrow transistors of size H are used to build current mirrors with a large multiplication ratio, low value current sources or high impedance resistors.

The two rows of digital gates adjacent to the analog part have separated transistor gates for the N-MOS and P-MOS, so that these transistors can also be used in an optimum way for analog functions.

The N-well of the P-MOS is divided into several isolated regions, allowing an optimum circuit design in case of different supply voltages (e.g. for voltage doublers, separate LCD supply, etc.).

DIODES

32 single emitter bipolar PNP substrate transistors and four 8-emitter structures are provided. They are mainly foreseen for temperature compensated bandgap voltage references.

Diode voltage (emitter-base voltage) @ $T_{amb} = 25^{\circ}\text{C}$:

$$V_D = 26\text{mV} \times \ln(I_D / I_S) + R_{eq} \times I_D \quad \text{with } I_S = 0.1\text{fA} \text{ and } R_{eq} = 150\Omega$$

RESISTORS

Value (kΩ)	Number	Tolerance (%)	TC (%/°C)
1	576	-25 +25	0.1
30	192	-30 +40	0.5
300	50	-30 +40	0.5
550	20	-30 +50	0.6

CAPACITORS

	Size 1	Size 2
Maximum floating capacitance	3pF	5pF
Substrate capacitance	0.25pF	0.4pF
Number of areas	64	16

The floating capacitors are built between the polysilicon and the metal, in areas where the polysilicon is covered only by a thin oxide layer which results in a high specific capacitance of 850pF/mm². The value of the capacitors is programmed by the size of the metal plate.

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PERIPHERY

The periphery consists of 40 identical cells containing one pad, three buffer transistors (2 N-MOS and 1 P-MOS) and two 15k Ω pullup/pulldown resistors. Each cell is programmable as supply, as input, as push-pull output, as open-drain output or as bidirectional I/O pin. The output transistors can also be connected as transmission gates. The transistors of adjacent cells can be connected together to increase the output drive capability.

The electrostatic discharge (ESD) structure which protects the pin against overvoltage is realized by one of the N-MOS having his source always connected to V_{SS} . This structure sustain ESD test pulses of more than 2kV (Generator impedance: 100pF, 1.5k Ω)

Size of the output transistors:	N-Buffer	192 μ m / 2.0 μ m
	P-Buffer	512 μ m / 2.0 μ m
	N-Protection	264 μ m / 2.2 μ m

Typical characteristics of the output transistors

